

 INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Docket Number (Optional) 17271	Application Number 10/723,225
	Applicant(s) Takehiro Nishiie	
	Filing Date November 26, 2003	Group Art Unit Unassigned

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<i>MK</i>		2002-17658	1/22/2002	Japan				
<i>MK</i>		2000-157484	6/13/2000	Japan				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER 	DATE CONSIDERED <i>9/2/5</i>
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INFORMATION DISCLOSURE CITATION
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Docket Number (Optional)
17271

Application Number **10/723225**
To be assigned

Applicant(s)
Takehiro Nishiie

Filing Date
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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
MK		5,634,880	6/3/1997	Feldman et al.			

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
MK		10-276968	10/20/1998	Japan			<input checked="" type="checkbox"/>	
MK		2000-157484	6/13/2000	Japan			<input checked="" type="checkbox"/>	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER **[Signature]**

DATE CONSIDERED **9/2/5**

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